

10/509359

Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128426		APPLICATION NO. New U.S. National Phase of Foreign Application No. 10/509359	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Hirokazu TADA et al.			
				FILING DATE August 14, 2006		GROUP	
U.S. PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Name			
	1	5,321,716	6/14/1994	KINOSHITA et al.			
	2	5,367,195	11/22/1994	DIGIACOMO et al.			
	3	5,420,073	5/30/1995	DIGIACOMO et al.			
	4	6,284,393 B1	9/4/2001	HOSOKAWA et al.			
FOREIGN PATENT DOCUMENTS							
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation	
	5	JP A 06-283622	10/7/1994	JAPAN	X	X	
	6	JP A 05-167195	7/2/1993	JAPAN	X	X	
	7	JP A 2003-282884	10/3/2003	JAPAN	X	X	
	8	JP A 2003-258265	9/12/2003	JAPAN	X	X	
	9	JP A 2001-189527	7/10/2001	JAPAN	X	X	
	10	JP A 2000-133464	5/12/2000	JAPAN	X	X	
	11	JP A 10-294182	11/4/1998	JAPAN	X	X	
	12	JP A 10-162959	6/19/1998	JAPAN	X	X	
OTHER DOCUMENTS							
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)					
	13	Hepp, Aline et al., "Light-Emitting Field-Effect Transistor Based on a Tetracene Thin Film," Physical Review Letters, Vol. 91, No. 15, 157406-1 to 157406-4 pp, 10 October, 2003.					
	14	Yahiro, Masayuki et al., "Electrical and optical characterization of organic field effect transistor using self-organized layered perovskite thin film," Tech. Report of IEICE OME2002-54, The Inst. of Elec., Info. and Comm. Eng., 37-41 pp, September 2002.					
EXAMINER		/Thao Le/			DATE CONSIDERED 09/20/2007		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: August 14, 2006

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /TL/